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## APPLICANTS

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\*\* CONTINUING DATA \*\*\* *SA*

THIS APPLICATION IS A 371 OF PCT/DE00/01836 06/06/2000

\*\* FOREIGN APPLICATIONS \*\*\* *SA*

GERMANY 199 33 841.8 07/20/1999

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY GERMANY	SHEETS DRAWING 3	TOTAL CLAIMS 35	INDEPENDENT CLAIMS 2
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## ADDRESS

26646

## TITLE

Device and method for etching a substrate using an inductively coupled plasma

FILING FEE RECEIVED 1290	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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